



# **Manufacturing Metrology Team – Instrument Data Sheet**

## Mitaka MLP-3SP



# **Purpose**

• Optical 3D measurement of surface form and texture





### Working principle

• The Mitaka MLP-3SP is a point autofocus measuring instrument. It measures surface texture by automatically focusing a laser beam at a point on a specimen surface, moving the specimen surface in a fixed measurement pitch using an XY scanning stage, and measuring the specimen surface height at each focused point. During measurement the autofocus sensor detects the laser spot displacement and feeds back the information to the autofocus mechanism in order to keep the objective at in-focus position.

## **Advantages**

- Large measuring range with high resolution
- High speed contour measurement
- Capable of measuring steep angles over 45 °
- High autofocus repeatability (nanometre level)
- Immune to surface reflectance properties
- Special objective setup for inner contour measurement

#### Limitations

- Long 3D measurement time compared to typical areal measurement instruments
- Smaller acceptable slope angle for specular surfaces
- Only one objective lens can be mounted

#### Related research focus

- Sphere roundness and profile measurement
- Optical lenses measurement
- Cutting tool profile measurement
- Surface texture measurement
- Small gear measurement
- Performance verification of the instrument for geometrical metrology
- Measurement uncertainty estimation



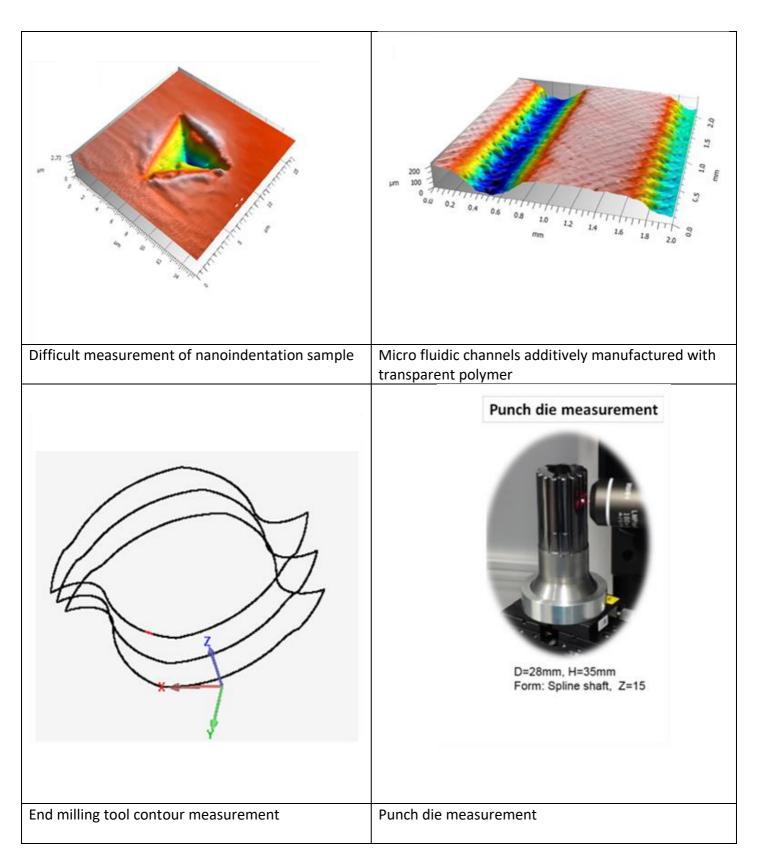


Instrument specifications				
Axis	Moving	Scale	Measuring	Positioning
	range	resolution	accuracy	repeatability
X	120 mm	10 nm	±4.4 μm / 120 mm	3 μm p-v
Υ	120 mm	10 nm	±4.4 μm / 120 mm	3 μm p-v
Z	130 mm	10 nm	±4.6 μm / 130 mm	3 μm p-v
AF	40 mm	1 nm	±2.8 μm / 40 mm	$\sigma$ =0.015 μm (100×)
				σ=0.015 μm (50×)
θ	360°	0.0002°	±0.01°	±0.005°



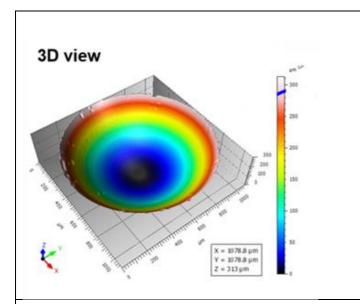


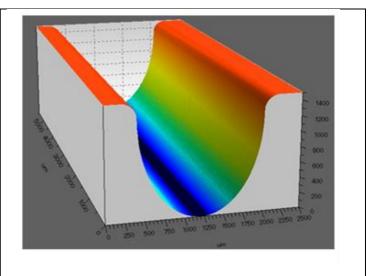
## **Measurement examples**





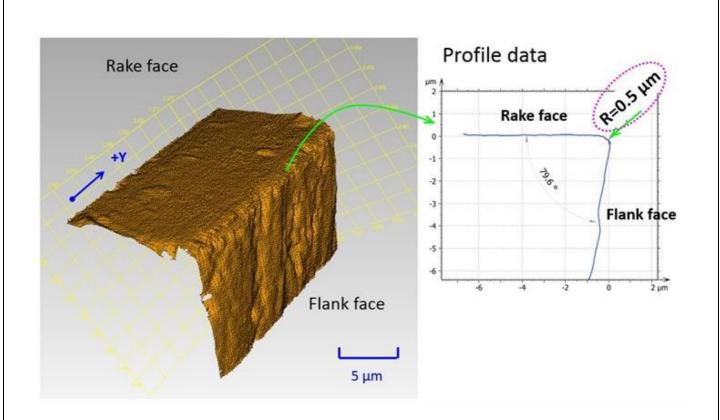






Spherical moulding die

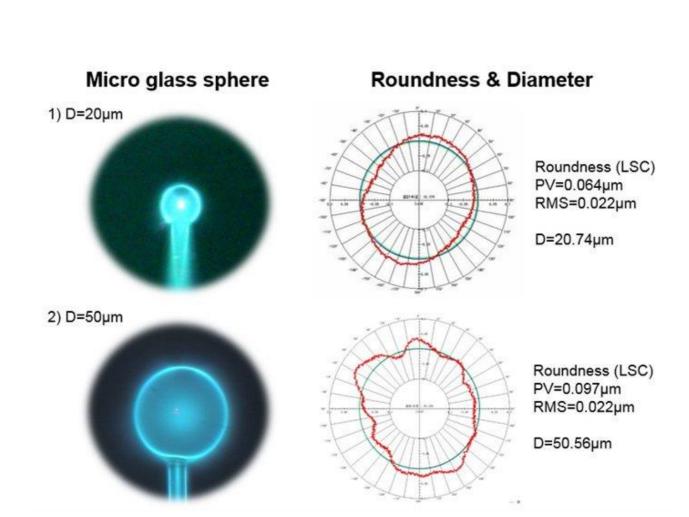
High-slope moulding die



Carbide micro cutting tool radius measurement





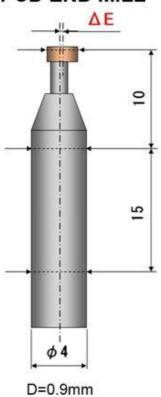


Measurement of micro sphere made from translucent material



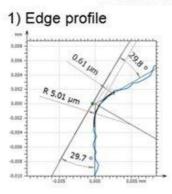


### PCD END MILL

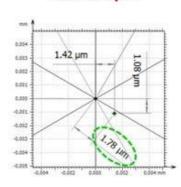


6 cutting edges

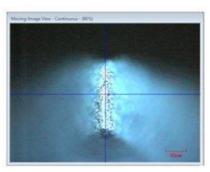
### Contour evaluation

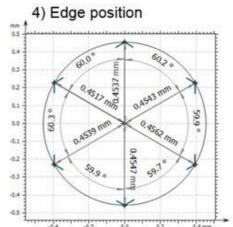


The eccentric amount against shaft center
ΔE=1.78μm



2) Microscope view (100x)

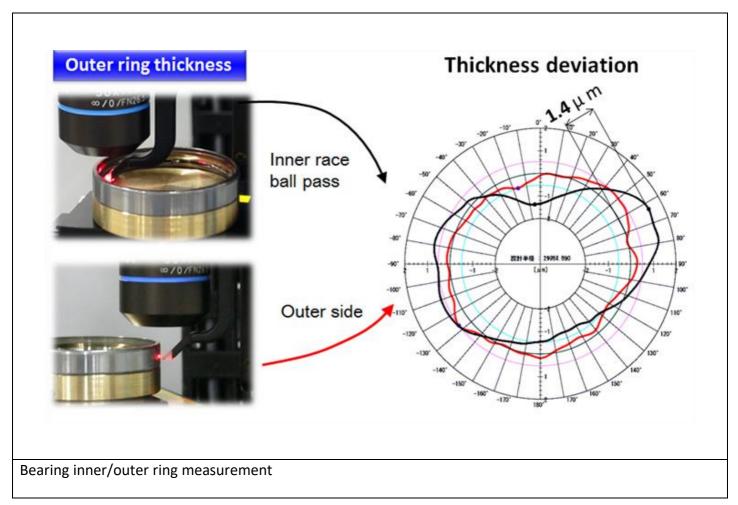




Cutting tool offset measurement







For contract measurement enquiries, please contact:

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